



Application of

Applicants

: Hinterdorfer et al

Serial No.

: 10/697,841

Filed

: October 30, 2003

Confirmation No.: 9286

Title

: **TOPOGRAPHY AND RECOGNITION IMAGING ATOMIC FORCE
MICROSCOPE AND METHOD OF OPERATION**

Docket No.

: MOL 0074 PA/40518.102

Examiner

: Cygan, Michael

Art Unit

: 2855

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

OFFICIAL

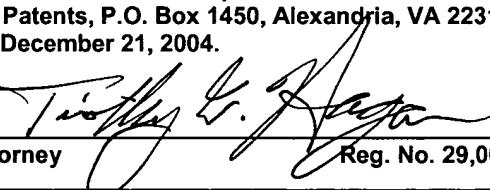
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 21, 2004.


Attorney

Reg. No. 29,001

AMENDMENT

This paper is being filed in response to the Office Action mailed July 30, 2004. A Request for a two-month extension of time in which to respond to this Action accompanies this paper making a response due date of December 30, 2004. Reconsideration is respectfully requested in light of the amendments and remarks below, which include, in order of appearance, beginning on separate sheets:

- Amendments to the Specification;
- Amendments to the Claims; and
- Remarks.